



Patent  
Attorney's Docket No. 015290-465

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Robert J. O'DONNELL et al.

Application No.: 09/749,921

Filed: December 29, 2000

For: CORROSION RESISTANT  
COMPONENT OF SEMICONDUCTOR  
PROCESSING EQUIPMENT AND  
METHOD OF MANUFACTURE  
THEREOF

)  
)  
) Group Art Unit: 2812  
)  
) Examiner: Not Yet Assigned  
)  
) Confirmation No.: 6804  
)  
)  
)

**INFORMATION DISCLOSURE STATEMENT  
TRANSMITTAL LETTER**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Enclosed is an Information Disclosure Statement and accompanying form PTO-1449 for the above-identified patent application.

- [X] No additional fee for submission of an IDS is required.
- [ ] The fee of \$180.00 (126) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- [ ] A certification under 37 C.F.R. § 1.97(e) is also enclosed.
- [ ] A certification under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (126) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.
- [ ] Charge \$\_\_\_\_\_ to Deposit Account No. 02-4800 for the fee due.
- [ ] A check in the amount of \$\_\_\_\_\_ is enclosed for the fee due.

The Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

P.O. Box 1404  
Alexandria, Virginia 22313-1404  
(703) 836-6620

By: Peter K. Skiff  
Peter K. Skiff  
Registration No. 31,917

Date: September 16, 2002

RECEIVED  
SEP 24 2002  
TC 1700



RECEIVED Patent  
SEP 16 2002  
Attorney's Docket No. 015290-465  
TC 2800 MAIL ROOM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Robert J. O'DONNELL et al.

Application No.: 09/749,921

Filed: December 29, 2000

For: CORROSION RESISTANT  
COMPONENT OF SEMICONDUCTOR  
PROCESSING EQUIPMENT AND  
METHOD OF MANUFACTURE  
THEREOF

)  
)  
) Group Art Unit: 2812

)  
) Examiner: Not Yet Assigned

)  
) Confirmation No.: 6804

RECEIVED  
SEP 24 2002  
TC 1700

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit copies of the Notification of Transmittal of the International Search Report or the Declaration dated August 21, 2002 and Written Opinion dated August 23, 2002 for a corresponding application. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents not previously cited in an Information Disclosure Statement is enclosed.

U.S. Publication No. US2001/0003271A1 to Otsuki, published June 14, 2001;

European Patent No. 0443778A1, published June 26, 1991;

European Patent Application No. 0845545A1, published June 3, 1998;

Japanese Abstracts of Japan Publication No. 11345780, published December 14, 1999;

Deronzier, J.C. et al., "Plate Heat Exchangers in Liquid-Crystal Polymers",  
Applied Thermal Engineering, Vol. 17, Nos. 8-10, pages 799-808, 1997;

Written Opinion dated August 23, 2002 for PCT/US01/43152;

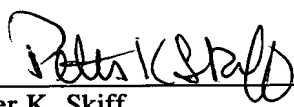
Notification of Transmittal of the International Search Report or  
the Declaration dated August 21, 2002 for PCT/US01/43152.

I, the undersigned, hereby certify that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

To assist the Examiner, the document is listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

By:   
Peter K. Skiff  
Registration No. 31,917

P.O. Box 1404  
Alexandria, Virginia 22313-1404  
(703) 836-6620

Date: September 16, 2002

